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Description

The inv ntion relates to an optical disc or photo-disc and in particular an optical disc having a high accuracy in shape and dim nsion of pits and grooves and an exc II nt stability of dim nsion of the substrate. The disc is formed from a polymer adapted to form the anisotropic melt phase. The polymer is melt-processable.

As data recording and reproducing discs of a type adapted to reproduce data by irradiating laser beams from one surface of the disc, with a recording layer (hereinafter called data pits) comprising pits and grooves formed on this disc surface and a metal coating layer formed on its exposed side, video- and audio-discs, etc., have been developed and recently have attained rapid progress. As disc materials of this type, hard vinyl chloride series resins, polycarbonate series resins, polymethyl methacrylate series resins, etc., are being studied. Such well-known photo-disc materials have following defects:

Thus the hard vinyl chloride series resins are inferior in formability and show defects due to the addition of a wide variety of compounding agents. For example, they involve a problem of plasticizer, etc., for improving their formability bleeding to the disc surface, resulting in reduced accuracy in reproduction.

The polycarbonate series resins, although being excellent in heat resistance, impact resistance, etc., have difficulty in formability; thus, it is difficult to exactly reproduce the fine undulations formed on the stamper for embossing the data pits on the substrate, also resulting in insufficient sensitivity and accuracy.

In contrast, the polymethyl methacrylate series polymers are excellent in transparency and non-optical rotation, but involves problems of lack of moisture resistance and low dimensional stability under ambient circumstances involving moisture and heat, etc. Morever, these resins are susceptible to cracking, being low in mechanical strength, particularly, shock resistance, and their hardness posing problems in formability.

Typical prior art optical discs are described and claimed in GB-A-2104412. This relates to discs comprising a substrate of synthetic resin (for example acrylic resin) including signal pits on one side thereof, a reflecting film layer (for example of aluminium) overlying the signal pits and a protective layer coated over the reflecting film later.

The present inventors made studies to find optimum resins for optical discs, and arrived at the invention by adopting as the substrate for the discs certain melt-processable polymers as defined below. Melt-processable polymers have the properties of permitting the polymer molecular chains to assume regular parallel arrangement in the molten state. This state is referred to as the liquid crystal state or the nematic phase of a liquid crystal substance. As taught by the Textbook of Polymer Science (ISBN 0-471-82834-3, page 3), other polymers, such as polystyrene, undergo considerable molecular orientation when subjected to stress at temperatures above Tg. One group of melt-processable polymers is disclosed in EP-A1-0067032. This document relates to a group of melt-processable polyesteramides with specific recurring mojeties of benzoyl, naphthoyl, dicarbonyl and divalent aromatic amine groups.

An optical disc according to the invention comprises a polymeric substrate, a recording layer having pits and grooves formed on said substrate and a metal coating layer formed on said recording layer, characterized in that the material said polymeric substrate is a melt-processable polymer selected from polyesters having an average molecular weight of 2000 to 200000 and polyester amides having an average molecular weight of 5000 to 50000, said polyesters and polyester amides are liquid crystal polymers capable of forming an anisotropic melt phase in the absence of stress.

The optical disc of the invention preferably comprises a light-transmitting, surface protecting layer on the metal coating layer. In a practical embodiment of the optical disc the recording layer has been placed only on one side of the substrate or on each side of the substrate. Another practical embodiment of the optical disc may be obtained by assembling two optical disc as defined above and attaching them to each other on the rear surfaces of the substrates.

According to the invention, the substrate is formed from the polymer and comprises the polymer which is in the anisotropic phase. In addition, the substrate may be formed from a polymer composition which comprises the polymer and another polymer.

Thus in composing the photo-disc of this invention, while on one surface of a substrate formed of a polymer composition adapted to form anisotropic melt phase and which is melt-processable, a recording layer comprising pits and grooves is formed, on the surface of said recording layer, a metal coating layer which pomposes a reflecting surface is formed; then, into this disc, no irradiation of laser beams is made from the substrate side, but reproduction of data is made possible by irradiating las repeats on the reflecting surface of the aforementioned metal coating from opposite side to the substrate.

The property of the anisotropic m It phase may be checked for sure by the commonly used method of polarization inspection based on utilization of orthogonal polarizers. Mor particularly, the confirmation of the anisotropic m It phase may be made by observing a sample put on a L itz hot stage at a multiplicity of 40

in nitrogen atmosphere, using a Leitz polarization microscope. The aforem ntioned polymers are optically anisotropic. Thus they permit light to pass through, when checked between orthogonal polarizers. If a sample is optically anisotropic, a polarized light will pass through it, even if it is in stationary state.

Mentioned as the components of the polymers adapted to form anisotropic melt phase such as the aforementioned

are:

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- ① Those comprising one or more of aromatic dicarboxylic acids and acryclic dicarboxylic acids;
- 2 Those comprising one or more of aromatic diols, acryclic diols and aliphatic diols;
- 3 Those comprising one or more of aromatic hydroxycarboxylic acids;
- 4 Those comprising one or more of aromatic thiol carboxylic acids;
- (5) Those comprising one or more of aromatic dithiols and aromatic thiol phenols; and
- (6) Those comprising one or more of aromatic hydroxyamines and aromatic diamines; and the polymers adapted to form anisotropic melt phase are composed of the following combinations:
- I) Polyesters formed of (1) and (2);
- II) Polyesters formed of 3 only;
- III) Polyesters formed of ①, ② and ③;
- IV) Polythiol esters formed of 4 only;
- V) Polythiol esters formed of ① and ⑤;
- VI) Polythiol esters formed of ①, ④ and ⑤;
- VII) Polyester amides formed of (1), (3) and (6); and
- VIII) Polyester amindes formed of ①, ②, ③ and ⑥.

Although not included in the categories of combinations of components above-mentioned, aromatic polyazomethines are included as polymers adapted to form anisotropic fused phase. Mensioned as particular examples of such polymers are: Poly (nitrilo-2-methyl-1,4-phenylenenitriloethylidene-1,4-phenylene ethylidene), poly (nitrilo-2-methyl-1,4-phenylene nitriloethylidene-1,4-phenylene methylidene) and poly (nitrilo-2-chloro-1,4-phenylene nitrilomethylidene-1,4-phenylene methylidene).

Further, although not included in the categories of the combinations of the aforementioned components, polyester carbonates are included as the polymers adapted to form anisotropic fused phase. Some of them essentially comprise 4-oxybenzoyl units, dioxyphenyl units, dioxycarbonyl units and terephthaloyl units.

In the following, such compounds which are usuable as components of I)-VIII) above-mentioned are listed hereunder:

Mentioned as aromatic dicarboxylic acids are: Aromatic dicarboxylic acids such as terephthalic acid, 4,4'-diphenyl dicarboxylic acid, 4,4'-triphenyl dicarboxylic acid, 2,6-naphthalene dicarboxylic acid, diphenyl ether-4,4'-dicarboxylic acid, diphenoxyethane-4,4'-dicarboxylic acid, diphenoxybutane-4,4'-dicarboxylic acid, diphenyl ether-3,3'-dicarboxylic acid, diphenyl ether-3,3'-dicarboxylic acid, diphenyl ether-3,3'-dicarboxylic acid, diphenyl ethane-3,3'-dicarboxylic acid, diphenyl ethane-1,6-dicarboxylic acid or alkyl, alkoxyl or halogen substitutes of the aforementioned aromatic dicarboxylic acids such as chloroterephthalic acid, dichloroterephthalic acid, bromoterephthalic acid, methyl terephthalic acid, dimethyl terephthalic acid, ethyl terephthalic acid, methoxyterephthalic acid and ethoxyterephthalic acid.

Mentioned as the acyclic dicarboxylic acids are: Acyclic dicarboxylic acids such as trans-1,4-cyclohexane dicarboxylic acid, cis-1,4-cyclohexane dicarboxylic acid, 1,3-cyclohexane dicarboxylic acid, etc., or alkyl, alkoxyl or halogen substitutes of the aforementioned acyclic dicarboxylic acids such as trans-1,4-(1-methyl)-cyclohexane-dicarboxylic acid, trans-1,4-(1-chloro)-cyclohexane dicarboxylic acid, etc.

Mentioned as aromatic diols are: Aromatic diols such as hydroquinone, resorcinol, 4,4'-dioxydiphenyl, 4,4'-dioxydiphenyl, 2,6-naphthalenedio, 4,4'-dioxydiphenyl ether, bis (4-oxyphenoxy)-ethane, 3,3'-dioxydiphenyl, 3,3'-dioxydiphenyl ether, 1,6-naphthalene diol, 2,2-bis(4-hydroxyphenyl) propane, 2,2-bis(4-hydroxyphenyl) methane, etc., or alkyl, alkoxyl or halogen substitutes of the aforementioned aromatic diols such as chlorohydroquinone, methyl hydroquinone, 1-butyl hydroquinone, phenyl hydroquinone, methoxyhydroquinone, phenoxyhydroquinone, 4-chlororesorcinol, 4-methyl resorcinol, etc.

Mentioned as the acrylic diols are: Acyclic diols such as trans-1,4-cyclohexanediol, cis-1,4-cyclohexanediol, trans-1,3-cyclohexanediol, cis-1,4-cyclohexanediol, cis-1,2-cyclohexanediol and trans-1,3-cyclohexanedimethanol or alkyl, alkoxyl or halogen substitutes of the aforementioned acyclic diols such as trans-1,4-(1-methyl) cyclohexanediol and trans-1,4-(1-chloro) cyclohexanediol

M ntion d as the aliphatic diols are: Straight chain or branch d aliphatic diols such as ethylene glycol, 1,3-propanediol, 1,4-butanediol, neopentyl glycol, etc.

M ntion d as the aromatic hydroxycarboxylic acids are: Aromatic hydroxycarboxylic acids such as 4-hydroxybenzoic acid, 3-hydroxyb nzoic acid, 6-hydroxy-2-naphthoic acid, 6-hydroxy-1-naphthoic acid, tc.,

or alkyl, alkoxyl or halogen substitutes of aromatic hydroxycarboxylic acids such as 3-methyl-4-hydroxybenzoic acid, 3,5-dimethyl-4-hydroxybenzoic acid, 2,6-dimethyl-4-hydroxybenzoic acid, 3-methoxy-4-hydroxybenzoic acid, 3-methoxy-4-hydroxybenzoic acid, 6-hydroxy-5-methyl-2-naphthoic acid, 3-chloro-4-hydroxybenzoic acid, 2-chloro-4-hydroxybenzoic acid, 2,3-dichloro-4-hydroxybenzoic acid, 3,5-dichloro-4-hydroxybenzoic acid, 2,5-dichloro-4-hydroxybenzoic acid, 3-bromo-4-hydroxybenzoic acid, 6-hydroxy-5-chloro-2-naphthoic acid, 6-hydroxy-5,7-dichloro-2-naphthoic acid, etc.

Mentioned as the aromatic mercaptocarboxilic acids are: 4-Mercaptobenzoic acid, 3-mercaptobenzoic acid, 6-mercapto-2-naphthoic acid, 7-mercapto-2-naphthoic acid, etc.

Mentioned as the aromatic dithiolds are: Benzene-1,4-dithiol, benzene-1,3-dithiol, 2,6-naphthalene dithiol and 2,7-naphthalene dithiols, etc.

Mentioned as the aromatic mercaptophenols are: 4-Mercaptophenol, 3-mercaptophenol, 6-mercaptophenol and 7-mercaptophenol, etc.

Mentioned as aromatic hydroxyamines and aromatic diamines are: 4-Aminophenol, 4-N-methyl-4-aminophenol, 1,4-phenylenediamine, N-methyl-1,4-phenylenediamine, N, N'-dimethyl-1,4-phenylenediamine, 3-aminophenol, 3-methyl-4-aminophenol, 2-chloro-4-aminophenol, 4-amino-1-naphthol, 4-amino-4'-hydroxydiphenyl, 4-amino-4'-hydroxydiphenyl ether, 4-amino-4'-hydroxydiphenyl methane, 4-amino-4'-hydroxydiphenyl sulfide, 4,4'-diaminophenyl sulfide (thiodianiline), 4,4'-diaminophenyl-sulfone, 2,5-diaminotoluene, 4,4'-ethylene dianiline, 4,4'-diaminodiphenyl methane (methylene dianiline), 4,4'-diaminodiphenyl ether (oxydianiline), etc.

Of the aforementioned polymers I) - VIII) composed of the aforementioned components, there exist those which are adapted to form anisotropic fused phase and those which are not, depending on their components, their composition ratios and sequence distributions in these polymers. The polymers used in accordance with this invention are restricted to those of the aforementioned polymers adapted to form anisotropic fused phase.

The polyesters of the aforementioned I), II) and III) and polyester amides of VIII), being polymers adapted to form anisotropic fused phase which are desirable for use in excercising this invention, may be produced by various ester forming methods which enable mutual reactions of organic monomer compounds having functional groups which play the role of forming the required repetitive units by condensation. For example, such functional groups of these organic monomer compounds may include carboxyl, hydroxyl, ester and acyloxy groups, acid halides and amine group. The aforementioned organic monomer compounds may be reacted with each other by fusion acidolytic process, while keeping any heat exchange fluid out of existence. According to this method, first, fused solution of the reaction materials is formed by heating the monomers together. As the reactions are continued, solid polymer particles become being suspended in the liquid. For the purpose of facilitating removal of volatile matters (e.g., acetic acid or water) which are produced as byproducts at the final stage of condensation, the system may be put under vacuum.

The slurry polymerization process may be employed for forming perfect aromatic polyesters which are preferred for used in excercising this invention. By this method, the solid product is obtained in the state of being suspended in a heat exchanging medium.

Whichever process, the aforementioned fusion acidolytic process or the slurry polymerization process, is employed, the organic monomer reaction materials which are to derive the perfect aromatic polyesters may be put to use for the reactions in their denatured form (thus, as lower acyl esters) in which the hydroxyl groups of such monomers at normal temperature are esterified. As lower acyl groups, those with carbon atoms approx. 2-4 in number are preferable. Preferably, acetic acid esters of such organic monomer reaction materials are put to use for the reactions.

Further mentioned as typical examples of catalyzers which are arbitrarily usable either in the fusion acidolytic process or slurry process are: Gaseous acid catalyzers, etc., such as dialkyl tin oxide (e.g., dibutyl tin oxide), diallyl tin oxide, titanium dioxide, antimony trioxide, alkoxytitanium silicate, titanium alkoxide, alkali and alkaline earth metal salts of carboxylic acids (e.g., zinc acetate), Lewis acids (e.g., BF₃), hydrogen halides (e.g., HCl), etc. The amounts of catalyzers used generally should be approx. 0.001 - 1% by weight, particularly, approx. 0.01 - 0.2% by weight, based on the total weight of monomers.

The perfect aromatic polymers suitable for use in exercising this invention show a tendency of being substantially insoluble in common solvents and therefore, they are not suitable for forming from solution. How ver, as alr ady described, these polymers permit easy forming by the ordinary fusion forming proc ss. Particularly desirable perfect aromatic polym rs are soluble in som degre in p ntafluorophenol.

The perfect aromatic polyesters pr ferable for use in xercising this invention generally should have weight averag molecular weights of approx. 2,000 - 200,000, preferably, approx. 10,000 - 50,000 and mor preferably, approx. 20,000 - 25,000. On the other hand the preferable perfect aromatic poly (ester-amides)

generally should have molecular weights of approx. 5,000 - 50,000, pr ferably, approx. 10,000 - 30,000, e.g., 15,000 - 17,000. Measur ment of such molecular weights may be made by gel perm ation chromatography and other standard m asuring methods which do not acc mpany solution forming of polymer, for example, by determining terminal groups by infrared spectroscopy on compression molded films. Or th measurement of molecular weight may be made by light scatt ring method on solution of polymer in pentafluorophenol.

The aforementioned perfect aromatic polyesters and polyester amides, when dissolved in pentafluorophenol at 60 °C at a concentration of 0.1 weight %, generally give logarithmic viscosity (I. V.) of at least approx. 2.0 dl/g, for example, approx. 2.0 - 10.0 dl/g.

The polyesters adapted to form anisotropic fused phase which are particularly desirable for use in exercising this invention should contain more than approx. 10 mol % of naphthalene part containing repetitive units such as 6-hydroxy-2-naphtoyl, 2,6-dioxynaphthalene and 2,6-dicarboxynaphthalene, etc. Desirable polyester amides should contain repetitive units of the aforementioned naphthalene part and another part comprising 4-aminophenol or 1,4-phenylene diamine.

Particular examples are given hereunder:

(1) Polyesters essentially composed of the following repetitive units I and II:

The polyesters contain approx. 10 - 90 mol % of unit I and approx. 10 - 90 mol % of unit II. In one mode, the units I exist up to approx. 65 - 85 mol %, preferably, approx. 70 - 80 mol % (e.g., about 75 mol %). In another mode, the units II exist at as far lower concentrations as approx. 15 - 35 mol %, preferably, approx. 20 - 30 mol %, and at least part of hydrogen atoms bonded to the ring(s) are allowed to be substituted, as the case may be, by any substituent radicals selected from among a group consisting of alkyl groups with number of carbon atoms 1 - 4, alkoxyl groups with number of carbon atoms 1 - 4, halogens, phenyls, substituted phenyls and their combinations.

(2) Polyesters essentially composed of the following repetitive units, I, II and III:

I
$$0 \longrightarrow C$$

II $0 \longrightarrow C$

These polyesters contain approx. 30 - 70 mol % of unit I. They should preferably, contain approx. 40 - 60 mol % of unit I, approx. 20 - 30 mol % of units II and approx. 20 - 30 mol % of unit III and at least part of hydrogen atoms bonded to the ring(s) are allowed to be substituted, as the case may be, by any substituent radicals selected from among a group consisting of alkyl groups with the number of carbons 1 - 4, alkoxyl groups with the number of carbons 1 - 4, halogens, phenyls, substrated phenyls and their combinations.

(3) Polyesters essentially composed of the following repetitive units I, II, III and IV:

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I
$$O \longrightarrow C$$

II $O \longrightarrow C$

II O

(where R means methyl, chloro, bromo or their combinations, being substituent radicals to hydrogen atoms on benzene ring(s).) They contain approx. 20 - 60 mol % of unit I, approx. 5 - 18 mol % of unit II, approx. 5 - 35 mol % of unit III and approx. 20 - 40 mil % of unit IV. These polyesters should preferably contain approx. 35 - 45 mol % of unit I, approx. 10 - 15 mol % of unit II, approx. 15 - 25 mol % of unit III and approx. 25 - 35 mol % of unit IV. Provided that sum total mol concentration of units II and III is substantially equal to the mol concentration of units IV. At least part of the hydrogen atoms which are bonded to the ring(s) are allowed to be substituted, as the case may be, by any substituent radical(s) selected from among a group consisting of alkyl radicals with the number of carbon atoms 1 - 4, halogens, phenyls, substituted phenyls and their combinations. These perfect aromatic polyesters, when dissolved at 60 °C in pentafluorophenol at a concentration of 0.3 W/V %, generally give their logarithmic viscosities at least 2.0 dl/g, e.g., 2.0 - 10.0 dl/g.

(4) Polyesters essentially composed of the following repetitive units I, II, III and IV:

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- Dioxyallyl unit represented by a general formula: { 0 Ar 0 } (where Ar means a divalent group having at least one benzene ring.)
- IV Dicarboxyallyl unit r presented by a gen ral formula

(where Ar' means a divalent group having at least one benzene ring)

They contain approx. 20 - 40 mol % of unit I, more than 10 mol % but less than approx. 50 mol % of unit II, more than 5 mol % but less than approx. 30 mol % of unit III and more than 5 mol % but less than approx. 30 mol % of unit IV. These polyesters should preferably contain approx. 20 - 30 mol % (e.g., approx. 25 mol %) of unit I, approx. 25 - 40 mol % (e.g., approx. 35 mol %) of unit II, approx. 15 - 25 mol % (e.g., approx. 20 mol %) of unit III and approx. 15 - 25 mol % (e.g., approx. 20 mol %) of unit IV. And at least part of hydrogen atoms bonded to the ring(s) are allowed to be substituted by any substituent radicals selected from among a group consisting of alkyl radicals with the number of carbon atoms 1 - 4, alkoxyl radicals with the number of carbon atoms 1 - 4, halogens, phenyls, substituted phenyls and their combinations.

The units !!! and IV should preferably be symmetric in the sense that the divalent bonds which are joining each one of them to other units on both sides thereof inside the polymer main chain are symmetrically arranged on 1 or 2 or more of benzene rings (for example, when they exist on a naphthalene ring, they are arranged mutually at para positions or at diagonal ring positions). However, non-symmetrical units which may be derived from resorcinol and isophthalic acid are also usable.

Desirable dioxyallyl unit III is:

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and desirable dicarboxyallyl unit is:

(5) Polyesters essentially composed of the following repetitive units I, II and III:

- II Dioxyallyl unit represented by a general formula { 0 Ar 0 } (where Ar means a divalent radical having at least one benzene ring)
 - III Dicarboxyallyl unit represented by a general formula

(where Ar' m ans a divalent radical containing at least one benzene ring)

They contain approx. 10 - 90 mol % of unit I, 5 - 45 mol % of unit II and 5 - 45 mol % of unit III. Thes polyesters should preferably contain approx. 20 - 80 mol % unit I, approx. 10 - 40 mol % of the unit II and approx. 10 - 40 mil % of the unit III. More preferably, they should contain approx. 60 - 80 mol % of unit I, approx. 10 - 20 mol % of unit II and approx. 10 - 20 mol % of unit III. And at least part of hydrogen atoms bonded to the ring(s) are allowed to be substituted, as the case may be, by any substituent radical(s) selected from among a group consisting of alkyl radicals with the number of carbon atoms 1 - 4, alkoxyl radicals with the number of carbon atoms 1 - 4, halogens, phenyls, substituted phenyls and their combinations.

Desirable dioxyallyl unit II should be:

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and desirable dicarboxyallyl unit III should be:

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(6) Polyester amides essentially composed of the following repetitive units I, II, III and IV:

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II A general formula

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(where A means a divalent radical having at least one benzene ring or divalent trans-cyclohexane radical)

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A general formula $\{Y - Ar - z\}$ (where Ar means a divalent radical having at least one benzene ring; Y represents O, NH or NR; and Z stands for NH or NR; where R means alkyl radicals or allyl radicals with the number of carbon atoms 1 - 6)

A general formula { O - Ar' - O } (where Ar' means a divalent radical having at least one benzene ring)

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They contain approx. 10 - 90 mol % of unit I, approx. 5 - 45 mol % of unit II, approx. 5 - 45 mol % of unit III and approx. 0 - 40 mol % of unit IV. And at least part of hydrogen atoms bonded to the ring(s) are allowed to be substituted, as the case may be, by any substituent radicals selected from among a group consisting of alkyl radicals with the number of carbon atoms 1 - 4, alkoxyl radicals with the number of carbon atoms 1 - 4, halogens, phenyls, substituted phenyls and their combinations.

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Desirable dicarboxylallyl unit II should be

desirable unit III should be

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and
and desirable dioxyallyl unit IV should be

Further, in the polymers adapted to form anisotropic melt phase of this invention, polymers in which part of their high molecular chain is composed of a segment of a polymer adapted to form anisotropic melt phase hereabove-described and the remaining part is composed of a segment of a thermoplastic resin not adapted to form anisotropic melt phase may be included.

The polymer composition of this invention adapted to form anisotropic melt phase and which is melt-processable may contain one or more of ① other polymers adapted to form anisotropic melt phase, ② thermoplastic resins not adapted to form anisotropic melt phase, ③ thermosetting resins, ④ low molecular organic compounds, ⑤ inorganic substances. The polymer segment adapted to form anisotropic melt phase and the remaining segment are allowed to be either thermodynamically compatible or not.

Included as the thermoplastic resins hereabove mentioned in ② are: e.g., polyethylene, polypropylene, polybutylene, polybutylene

Included as the thermosetting resins mentioned hereabove in ③: e.g., phenol resins, epoxy resins, melamine resin, urea resins, unsaturated polyester resins, alkid resins, etc.

Included as the low molecular organic compounds mentioned hereabove in ④ are: for example, substances which are to be added to general thermoplastic resins and thermosetting resins, which thus, include low molecular organic compounds used as plasticisers, light- and weather-proofing stabilizers like antioxidants or ultraviolet ray absorbers, etc., antistatic agents, fire retardants, coloring agents like dyes, pigments, etc., blowing agents, further, divinyl series compounds, bridging agents like peroxides or vulcanizing agents, etc., and lubricants for improving fluidity and mold releasing property, etc.

Further included as the inorganic substances mentioned hereabove in ⑤ are: e.g., materials to be added to general thermoplastic resins and thermosetting resins, which thus, include general inorganic fibers such as glass fibers, carbon fibers, metal fibers, ceramic fibers, boron fibers, asbestos, etc., powdery materials such as calcium carbonate, highly dispersible silicic acid, alumina, aluminum hydroxide, talc powder, mica, glass flake, glass beas, quartz powder, silica sand, various metal powders, carbon black, barium sulfate, calcined plaster, etc., inorganic compounds such as silicon carbide, alumina, boron nitride, silicon nitride, etc., and whisk rs and m tal whiskers, etc.

Brief Description of the Drawings:

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FIG. 1 is a schematic sectional view illustrating the photo-disc of this invention; and FIG. 2 is a sch matic sectional view showing another example.

1 Substrate

2 Data pits

3 Reflection

4 Transparent resin

In the following, as briefly describing the manufacturing method of the photo-disc of this invention, first, according to the ordinary method, a conductive film is formed on a photo-resist surface of a glass substrate by vapor-deposition or nonelectrolytic plating process; thereafter, the work is subjected to electrocasting of nickel and a master board, mother board and a matrix (stamper) for mass reproduction are fabricated. Then using this stamper as the matrix, the polymer composition of this invention adapted to form anisotropic melt phase and which is melt-processable is extruded and by way of injection molding, compression molding, etc., the disc substrate 1 as shown in FIG. 1 is formed and grooves 2 as data pits are formed in relief simultaneously therewith. Then a metal coating layer 3 is formed on the surface formed with the data pits 2. The type of metal of the metal coating layer 3 is not particularly limited, but the commonest ones are aluminum, chromium, gold, silver, copper, tin, etc., and for the method of forming the coating layer, vapor-deposition, spattering, ion-plating and all other methods which have heretofore been known may be employed. Its thickness is not subject to particular limitation so far as the aforementioned reflectivity can be effectively exhibited, but the most typical range where requirements in both phases of characteristics and economy of said coating layer are met is about 50 - 150nm(500 - 1,500A), preferably about 70 - 80nm (700 - 800A).

In the photo-disc of this invention, on the surface of the metal coating layer 3, a light transmitting layer doubled as a protective layer 4 is further provided. Because the polymer used according to this invention adapted to form anisotropic melt phase, which is used in exercising this invention, is opaque, the laser beam irradiation is not made from the substrate side, but, as shown by an arrow mark in FIG. 1, the laser beam is irradiated on the metal coating layer from the opposite side thereto. It is for this reason that the surface protecting layer 4 for the metal coating layer 3 needs to be formed of a transparent resin so that it can play the role of light transmitting layer. As such transparent resins, acrylic ultraviolet ray setting resins, methacrylic resins, urethane resins, silicone resins, epoxy resins, etc. may be mentioned.

While in the aforementioned example, a sheet of disc substrate 1 is so arranged that the recorded data may be reproduced from one side surface only, if, as shown in FIG. 2, two such sheets are put together with an adhesive such that they face each other on the side on which no metal coating layer is provided, then, both front and back surfaces may be utilized as the record reproducing surfaces.

Effects of the present invention which is roughly composed as hereabove described are summarized as follows:

- 1) The compositions of this invention have higher dimensional stability than acrylic resins, polycarbonates, etc., under ambient circumstances involving moisture, heat, etc.
- 2) They give smaller percentage of molding shrinkage and higher accuracy in shape and dimensions, when subjected to extrusion molding, than acrylic resins, polycarbonates, etc.
- 3) They, having excellent formability, can truely reproduced fine and dense undulations of a stamper and give high accuracy in recording and reproduction of data.

Example 1:

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With a photo-disc stamp r insert d in a mold, a polymer A adapted to form anisotropic melt phase, which is later-d scribed, was injection-mold d at 300°C cylinder temperature. 2.04KPa (200 Kg/cm²) injection pressure and 80°C mold temperature, yielding a photo-disc substrate (1) 120 mm in diameter and 1.2 mm thick. On the data pit (2) surface side of this disc substrate, approx. 50nm (500Å) aluminium film (3) was vapor-deposited, on which an ultraviolet ray setting acrylic resin was coated, followed by ultraviolet-ray-

setting, th reby forming a surface protective layer (4) approx. 10 μ m thick. The photo-disc thus obtained was left standing for 48 hours at a temperature and humidity of 40 °C and 90% RH to examine whether th disc show any deformation and warp. Under the similar molding conditions, a test piece was formed and with it, impact strength (ASTM D-256), coefficient of linear expansion (ASTM D-696) and percentage of molding shrinkage were measured.

Example 2-3:

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Experiments were carried out similarly as in Example 1 except that the resin with which to form the disc substrate was altered respectively to polymers B and C adapted to form anisotropic melt phase, which are described later.

15 Comparison Example 1:

From polymethacrylate resin for photo-disc, a disc substrate was injection-molded by the similar method as in Example 1 [cylinder temperature: 260°C, injection pressure: 0.51KPa (50 kg/cm²), mold temperature: 70°C]. Then with the metal coating and the surface protective layer formed on this disc substrate similarly as in Example 1, similar tests were conducted.

Comparison Example 2:

From a polycarbonate resin for photo-disc, a disc substrate was injection-molded by the similar method as that of Example 1 [cylinder temperature 290° C, injection pressure 0.82KPa (80 kg/cm²), mold temperature 80° C].

Then experiments were conducted similarly as in Comparison Example 1.

Results of experiments of Examples and Comparison Examples are summarily put up in Table 1.

It should be noted that polymers A, B and C adapted to form anisotropic melt phase, which were used as resins for forming substrates, have the following construction units:

Particular manufacturing methods of the aforementioned resins A, B and C are described h reunder:

<Resin A>

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1081 Parts by weight of 4-acetoxy-benzoic acid, 460 parts by weight of 6-acetoxy-2-naphthoic acid, 166 parts by w ight of isophthalic acid and 194 parts by w ight of diac toxybenz ne w re charg d into a reaction vessel equipped with a stirrer, nitrogen inlet pipe and distillate discharge pipe and the mixture was heated to 260° C in nitrogen current. It is, then, violently stirred for 2.5 hours at 260° C and then, for 3 hours at 280° C, while letting acetic acid be distilling out of the reaction vessel. Further, its temperature was raised to 320° C and the letting-in of nitrogen was stopped; thereafter, the pressure inside the reaction vessel was gradually lowered, the pressure being brought down to 13.3 Pa (0.1 mmHg)15 minutes later, followed by stirring for 1 hour at this temperature and pressure.

The polymer thus obtained had an intrinsic viscosity of 5.0, as measured in pentafluorophenol at 0.1% by weight concentration and at 60 °C.

<Resin B>

1081 Parts by weight of 4-acetoxybenzoic acid, 489 parts by weight of 2,6-diacetoxynaphthalene and 332 parts by weight of terephthalic acid were put into a reaction vessel equipped with a stirrer, nitrogen inlet pipe and distillate discharge pipe and this mixture was heated to 250°C in nitrogen current. Then it was violently stirred for 2 hours at 250°C and then, for 2.5 hours at 280°C, while letting acetic acid be distilling out of the reaction vessel. Further, its temperature was raised to 320°C and the letting-in of nitrogen was stopped; thereafter, the pressure inside the reaction vessel was gradually lowered, the pressure being reduced to 26.6 Pa (0.2 mmHg)30 minutes later, followed by stirring for 1.5 hours at this temperature and pressure.

The polymer thus obtained had its intrinsic viscosity of 2.5, as measured in pentafluorophenol at 0.1% by weight concentration and at 60 °C.

<Resin C>

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1261 Parts by weight of 4-acetoxybenzoic acid and 691 parts by weight of 6-acetoxy-2-naphthoic acid were put into a reaction vessel equipped with a nitrogen inlet pipe and distillate discharge pipe and this mixture was heated to 250°C in nitrogen current. It was violently stirred for 3 hours at 250°C and then, for 2 hours at 280°C, while letting acetic acid be distilling out of the reaction vessel. Further, its temperature was raised to 320°C and the letting-in of nitrogen was stopped; thereafter, the pressure inside the reaction vessel was lowered, the pressure being reduced to 13.3 Pa (0.1 mmHg)20 minutes later, followed by stirring for 1 hour at this temperature and pressure.

The polymer thus obtained had its intrinsic viscosity of 5.4, as measured in pentafluorophenol at 0.1% by weight concentration and 60 °C.

Table 1

40	Physi prop Example	cal erty	Deforma- tion and warp	Impact strength (Notched bar) (kg·cm/cm)	Coefficient of linear expansion (×10 ⁻⁵ (cm/cm/°C)	
45	Example	1	Not found	40	0.1	0.2
	*	2	Not found	45	0.2	0.3
50	**	3	Not found	46	0.1	0.2
	Comparison Example 1		Found	2.0	6	0.7
55		2	Found	38	7	0.6

Claims

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- 1. An optical disc which compris s a polymeric substrat, a recording layer having pits and groov s formed on said substrate and a m tal coating lay r form d n said recording layer, characterized in that the material of said polymeric substrate is a melt-processable polymer selected from polyesters having an average molecular weight of 2000 to 200000 and poly ster amid s having an av rage molecular weight of 5000 to 50000, said polyesters and polyester amides are liquid crystal polymers capable of forming an anisotropic melt phase in the absence of stress.
- 2. An optical disc as claimed in claim 1, wherein the polymeric substrate comprises a fully aromatic polyester having an average molecular weight of 20000 to 25000.
 - 3. An optical disc as claimed in claim 1 or claim 2, wherein the polymeric substrate comprises a polyester containing more than 10 mol % of naphthalene-moiety repetitive units.
 - An optical disc as claimed in claim 1, wherein the polymeric substrate comprises a fully aromatic
 polyester amide having an average molecular weight of 10000 to 30000.
- 5. An optical disc as claimed in claim 1, wherein the polymeric substrate comprises a polyester containing repetitive units of a naphthalene part and another part comprising 4-aminophenol or 1,4-phenylene diamine.
 - 6. An optical disc as claimed in any preceding claim, which further comprises a light-transmitting, surface-protecting layer on the metal coating layer.
 - 7. An optical disc as claimed in claim 6, wherein the light-transmitting, surface-protecting layer has been formed of a transparent resin.
- 8. An optical disc obtained by assembling two optical discs as claimed in claim 6 or claim 7 by attaching them to each other on the rear surfaces of the substrates.

Revendications

- 35 1. Un disque optique qui comprend un substrat polymère, une couche d'enregistrement comportant des microcuvettes et des sillons formée sur ledit substrat et une couche de revêtement métallique formée sur ladite couche d'enregistrement, caractérisé en ce que la matière dudit substrat polymère est un polymère façonnable à l'état fondu choisi parmi les polyesters ayant un poids moléculaire moyen de 2000 à 200 000 et les polyesteramides ayant un poids moléculaire moyen de 5000 à 50 000, lesdits polyesters et polyester-amides étant des polymères à cristaux liquides capables de former une phase fondue anisotrope en l'absence de contrainte.
 - 2. Un disque optique tel que revendiqué dans la revendication 1, dans lequel le substrat polymère comprend un polyester entièrement aromatique ayant un poids moléculaire moyen de 20 000 à 25 000.
 - 3. Un disque optique tel que revendiqué dans la revendication 1 ou la revendication 2, dans lequel le substrat polymère comprend un polyester contenant plus de 10 moles % de motifs récurrents à fragment naphtalénique.
- 50 4. Un disque optique tel que revendiqué dans la revendication 1, dans lequel le substrat polymère comprend un polyester-amide entièrement aromatique ayant un poids moléculaire moyen de 10 000 à 30 000.
- 5. Un disque optiqu tel que revendiqué dans la rev ndication 1, dans lequ 1 l substrat polymèr comprend un polyester contenant des motifs récurrents d'une portion naphtalénique et d'une autre portion comprenant du 4-aminophénol ou de la 1,4-phényl` nediamine.
 - 6. Un disque optique tel que revendiqué dans l'une quelconque des revendications précédentes, qui

comprend de plus une couche de protection de surface, transmettant la lumière, disposée sur la couch de revêtem nt métallique.

- 7. Un disque optique tel qu rev ndiqué dans la revendication 6, dans lequel la couche de protection de surfac , transmettant la lumière, a été formée d'une résine transparente.
- 8. Un disque optique obtenu en assemblant deux disques optiques tels que revendiqués dans la revendication 6 ou la revendication 7, en les fixant l'un à l'autre sur les surfaces arrière des substrats.

Ansprüche

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- 1. Optische Platte, umfassend ein polymeres Substrat, eine auf dem Substrat gebildete Aufzeichnungsschicht mit Kratern und Rillen und eine auf der Aufzeichnungsschicht gebildete Metall-Überzugsschicht, dadurch gekennzeichnet, daß das Material des polymeren Substrats ein in der Schmelze verarbeitbares Polymer ist, das aus Polyestern mit einem mittleren Molekulargewicht von 2 000 bis 200 000 und Polyesteramiden mit einem mittleren Molekulargewicht von 5 000 bis 50 000 ausgewählt ist, wobei diese Polyester und Polyesteramide Flüssigkristall-Polymere sind, die befähigt sind, in Abwesenheit einer Spannungsbeanspruchung eine anisotrope Schmelzphase zu bilden.
- Optische Platte nach Anspruch 1, worin das polymere Substrat einen vollaromatischen Polyester mit einem mittleren Molekulargewicht von 20 000 bis 25 000 umfaßt.
- 3. Optische Platte nach Anspruch 1 oder Anspruch 2, worin das polymere Substrat einen Polyester umfaßt, der mehr als 10 Mol-% Repetiereinheiten der Naphthalin-Struktureinheit umfaßt.
 - 4. Optische Platte nach Anspruch 1, worin das polymere Substrat einen vollaromatisches Polyesteramid mit einem mittleren Molekulargewicht von 10 000 bis 30 000 umfaßt.
- 5. Optische Platte nach Anspruch 1, worin das polymere Substrat einen Polyester umfaßt, der Repetiereinheiten eines Naphthalin-Teils und einen anderen, 4-Aminophenol oder 1,4-Phenylendiamin enthaltenden Teil umfaßt.
- 6. Optische Platte nach irgendeinem vorhergenden Anspruch, weiterhin umfassend eine lichtdurchlässige Oberflächen-Schutzschicht auf der Metall-Überzugsschicht.
 - 7. Optische Platte nach Anspruch 6, worin die lichtdurchlässige Oberflächen-Schutzschicht aus einem transparenten Harz gebildet wird.
- 40 8. Optische Platte, erhalten durch Zusammenbau zweier optischer Platten nach Anspruch 6 oder Anspruch 7 durch Befestigung beider aneinander auf den rückseitigen Oberflächen der Substrate.

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Fig. 1

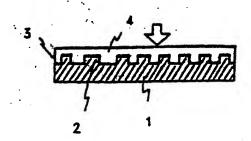


Fig. 2

